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## BIB DATA SHEET

CONFIRMATION NO. 3254

<b>SERIAL NUMBER</b> 10/524,980	<b>FILING or 371(c) DATE</b> 03/22/2006 <b>RULE</b>	<b>CLASS</b> 430	<b>GROUP ART UNIT</b> 2823	<b>ATTORNEY DOCKET NO.</b> 067538-5172US		
<b>APPLICANTS</b> Yoshihide Senzaki, Aptos, CA; Sang-In Lee, Cupertino, CA; Sang-Kyoo Lee, Seoul, KOREA, REPUBLIC OF; <b>** CONTINUING DATA *****</b> <input type="checkbox"/> Yes <input checked="" type="checkbox"/> HL This application is a 371 of PCT/US03/26083 08/18/2003 which claims benefit of 60/404,363 08/18/2002 <b>** FOREIGN APPLICATIONS *****</b> <input type="checkbox"/> None <input checked="" type="checkbox"/> HL <b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** ** SMALL ENTITY **</b>						
Foreign Priority claimed <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No 35 USC 119(a-d) conditions met <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No Verified and Acknowledged <u>/HSIEN MING LEE/</u> Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	<b>STATE OR COUNTRY</b> CA	<b>SHEETS DRAWINGS</b> 2	<b>TOTAL CLAIMS</b> 27	<b>INDEPENDENT CLAIMS</b> 2
<b>ADDRESS</b> MORGAN, LEWIS & BOCKIUS, LLP. (PA) 2 PALO ALTO SQUARE 3000 EL CAMINO REAL PALO ALTO, CA 94306 UNITED STATES						
<b>TITLE</b> Low temperature deposition of silicon oxides and oxynitrides						
<b>FILING FEE RECEIVED</b> 1380	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees			
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